

**Search Notes**

Application/Control No.

10/660,306

Examiner

Christopher K. Agrawal

Applicant(s)/Patent under  
Reexamination

LIU, HEBEN

Art Unit

3726

**SEARCHED**

Class	Subclass	Date	Examiner
29	890.032	1/11/2006	CKA
	890.046	1/11/2006	CKA
	890.05	1/11/2006	CKA

**INTERFERENCE SEARCHED**

Class	Subclass	Date	Examiner

**SEARCH NOTES  
(INCLUDING SEARCH STRATEGY)**

	DATE	EXMR
see attached EAST workspace for search history	1/11/2006	CKA
consulted Examiner Compton regarding field of search	1/11/2006	CKA